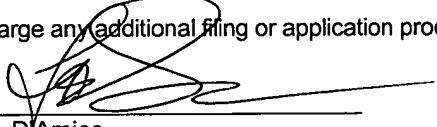




2813

AMENDMENT TRANSMITTAL LETTER				Docket No. M4065.0319/P319	
Application No. 09/296,835		Filing Date April 22, 1999		Examiner Erik Kielin	
				Art Unit 2813	
Applicant(s): Ronald A. Weimer, et al.					
Invention: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS					
<b>TO THE COMMISSIONER FOR PATENTS</b>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
<b>CLAIMS AS AMENDED</b>					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	12	- 40 =		x	0.00
Independent Claims	5	- 8 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>					
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this amendment.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge and credit Deposit Account No. <u>04-1073</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Thomas J. D'Amico Attorney Reg. No.: 28,371 DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP 2101 L Street NW Washington, DC 20037-1526 (202) 828-2232				Dated: <u>September 22, 2003</u>	

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#40 / Formal Drawing  
Docket No.: M4065.0319/P319  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

9/30/03

John H

In re Patent Application of:  
Ronald A. Weimer, et al.

Application No.: 09/296,835

Art Unit: 2813

Filed: April 22, 1999

Examiner: Erik J. Kielin

For: FABRICATION OF DRAM AND OTHER  
SEMICONDUCTOR DEVICES WITH AN  
INSULATING FILM USING A WET  
RAPID THERMAL OXIDATION PROCESS

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SUBMISSION OF FORMAL DRAWINGS

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Arlington, VA 22202

Dear Sir:

Submitted herewith is one set (seven sheets) of formal drawings for filing in the above-identified patent application. Kindly substitute the enclosed formal drawings for the informal drawings submitted with the originally filed application.

Dated: September 22, 2003

Respectfully submitted,

By

Thomas J. D'Amico

Registration No.: 28,371

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